NASA Case No. LEW 17,222-2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ok

Okojie, et al

Serial No:

(TO BE ASSIGNED)

Filed:

HEREWITH

For:

"Silicon Carbide High Temperature Anemometer and Method of

Assembling the Same "

Art Unit:

(TO BE ASSIGNED)

Examiner:

(TO BE ASSIGNED)

PRELIMINARY AMENDMENT

Commissioner for Patents Mail Stop: New Application P.O. Box 1450 Alexandria, VA 22313-1450

Dear Commissioner:

This amendment relates to the patent application for NASA docket number LEW 17,222-2, which is filed concurrently with this amendment. This application is a <u>DIVISIONAL</u> <u>APPLICATION</u> of parent case Serial No. 10/233,182, (NASA Case No. LEW 17,222-1) which was filed on 8/29/2002. This divisional application claims priority to the parent case's filing date.

In said parent case, pursuant to the restriction requirement imposed in a June 26, 2003 telephone call from Examiner Corey Mack to the undersigned, applicant elected to prosecute claims #1-16, which are directed to a product. In that parent case, claims 17-22, which are directed to a method, were canceled without prejudice. In this divisional application, applicant seeks to prosecute claims 17-22.

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Per the revision to 37 CFR 1.121, this Amendment is submitted in the new format. Accordingly, each section begins on a new page. Strikethroughs are used to denote items deleted, and underlining is used to denote items inserted. For single characters like punctuation marks where strikethroughs do not clearly appear, double brackets have been used to denote items deleted.

It is respectfully requested that the application be amended as follows: